



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78681

Takayasu YAMAMOTO, et al.

Appln. No.: 10/721,381

Group Art Unit: 2877

Confirmation No.: 6006

Examiner: Sang H. NGUYEN

Filed: November 26, 2003

For: INSPECTING DEVICE FOR SEMICONDUCTOR WAFER

**COMMENTS ON STATEMENT OF
REASONS FOR ALLOWANCE**

MAIL STOP ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated January 28, 2005 and the accompanying Statement of Reasons for Allowance, Applicant submits the following comments:

COMMENTS

The Notice of Allowability also includes an Examiner's Statement of Reasons for Allowance. Applicant believes the Examiner's statements are inaccurate since they may be construed to imply that all the claims recite the language quoted from claim 1, which is not the case. Applicant submits that the allowed claims speak for themselves, and do not require additional clarification to determine their respective scopes.

Comments on Statement of
Reasons for Allowance
U.S. Application No. 10/721,381

Attorney Docket No.: Q78681

Please enter Applicant's comments into the above-identified application. No response
from the Examiner is deemed to be necessary.

Respectfully submitted,



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Date: April 27, 2005